



PTO/SB/08A (10-01)
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Substitute for form 1449A/PTO		Complete if Known			
		Application Number	10/657,793		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Filing Date	9/8/2003		
		First Named Inventor	Norris et al.		
		Art Unit	2185		
		Examiner Name	KIM, Hong Chong		
Sheet	1	of	2	Attorney Docket Number	CML00107D-P01

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)				
H ↑		3,718,912		Feb-73	Hasbrouck et al.	
		4,760,545		Jul-88	Inagami et al.	
		4,825,361		Apr-89	Omoda et al.	
		4,807,183		Feb-89	Kung et al.	
		5,367,494		Nov-94	Shebanow et al.	
		5,495,817		Feb-96	Tamada	
		6,052,766		Apr-00	Betker et al.	
		6,173,389		Jan-01	Pechanek et al.	
		5,652,909		Jul-97	Kodosky	
		6,437,804		Aug-02	Ibe et al.	
		6,442,701		Aug-02	Hurd	
		6,571,016		May-03	Mehrotra et al.	
		5,734,863		Mar-98	Kodosky et al.	
		5,790,877		Aug-98	Nishiyama et al.	
		5,805,614		Sep-98	Norris	
		5,821,934		Oct-98	Kodosky et al.	
		5,881,257		Mar-99	Glass et al.	
		5,881,263		Mar-99	York et al.	
		5,893,143		Apr-99	Tanaka et al.	
		5,936,953		Aug-99	Simmons	
	5,966,528		Oct-99	Wilkinson et al.		
	5,969,975		Oct-99	Glass et al.		
	5,999,736		Dec-99	Gupta et al.		
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	6,128,775		Oct-00	Chow et al.		
	6,192,384		Feb-01	Daily et al.		
		US-				

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ²
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				

Examiner Signature	H. Kim	Date Considered	3/30/06
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Sheet	2	of	2		

FOREIGN PATENT DOCUMENTS						
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Substitute for form 1449B/PTO		Complete if Known	
		Application Number	10/657,793
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Filing Date	9/8/2003
		First Named Inventor	Norris et al.
		Art Unit	2185
		Examiner Name	KIM, Hong Chong
		Attorney Docket Number	CML00107D-P01
Sheet	1	of	1

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
HL		LAM, M., Software Pipelining: An Effective Scheduling Technique for VLIW Machines, Proceedings of the SIGPLAN '88 Conference on Programming Language Design and Implementation, Atlanta, Georgia, June 22-24, 1988, pp. 318-328	
		LEE, T. et al., A Transformation-Based Method for Loop Folding, IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems, Vol. 13, No. 4, April 1994, pp. 439-450	
		KAVI, K.M. et al., A Formal Definition of Data Flow Graph Models, IEEE Transactions on Computers, Vol C-35, No. 11, Nov 1986, pp. 940-948	
		COOPER, K.D. et al., Efficient Computation of Flow Insensitive Interprocedural Summary Information, SIGPLAN Notices, Vol. 19, No. 6, June 1984, pp. 247-258	
		STRONG, H.R., Vector Execution of Flow Graphs, Journal of the Association for Computing Machinery, Vol 39, No. 1, January 1983, pp. 186-196	
HL		AIKEN, A. et al., Resource-Constrained Software Pipelining, IEEE Transactions on Parallel and Distributed Systems, Vol. 6, No. 12, December 1995, pp. 1248-1270	

Examiner Signature	H. Kim	Date Considered	3/30/06
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